



AFV  
JFW

PATENT  
81877.0012  
Customer No. 26021

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:  
Seiyo NAKASHIMA, et al.  
Serial No: 09/816,643  
Confirmation No: 6862  
Filed: March 23, 2001  
For: Substrate Processing Apparatus  
and Substrate Processing Method

Art Unit: 1763  
Examiner: Kackar, Ram N.

PETITION FOR EXTENSION OF TIME

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

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October 25, 2005

Date of Deposit

Juanita Soberanis

Name

*Juanita Soberanis* 10/25/2005

Signature

Date

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Commissioner for a five-month extension of time extending to October 25, 2005, from which a Notice of Appeal was filed on March 25, 2005 in response to the Final Office Action dated September 27, 2004. The extension is sought for the purpose of maintaining pendency so that a continuation application of this case may be filed. Please charge the fee of \$2,160 for this extension to Deposit Account No. 50-1314.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: October 25, 2005

By:

*Lawrence J. McClure*

Lawrence J. McClure  
Registration No. 44,228  
Attorney for Applicant(s)

500 South Grand Avenue, Suite 1900  
Los Angeles, California 90071  
Phone: 213-337-6700  
Fax: 213-337-6701

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